



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Mitsushi FUJIKI**

Group Art Unit: **2823**

Application Number: **10/772,253**

Examiner: **Thanh V. Pham**

Filed: **February 6, 2004**

Confirmation Number: **6491**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE
INCLUDING A LOW-TEMPERATURE LOWER ELECTRODE-
FORMING STEP**

Attorney Docket Number: **042068**

Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. §1.116
EXPEDITED PROCESSING REQUESTED

MAIL STOP AF

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

March 10, 2006

Sir:

In response to the Office Action dated November 29, 2005, the response date of which having been extended by one month to March 28, 2006, Applicants submit the following remarks, which begin on page 2 of this paper.